

Sir:

Transmitted herewith for filing is the Patent Application of:

Inventor: **CHII-MING WU, MING-HSING TSAI, CHING-HUA HSIEH, SHAU-LIN SHUE**

For: **METHOD OF MANUFACTURING A CONTACT INTERCONNECTION LAYER CONTAINING A METAL AND NITROGEN BY ATOMIC LAYER DEPOSITION FOR DEEP SUB-MICRON SEMICONDUCTOR TECHNOLOGY**

Enclosed are:

- ☒ **6** sheets of drawing(s) - formal.
- ☒ An assignment of the invention to **Taiwan Semiconductor Manufacturing Co.**
- ☐ An associate power of attorney ☐ Applicant claims small entity status
- ☐ Request & Certification under 35 USC 122(b)(2)(b)(i)

The filing fee has been calculated as shown below:

	(Col. 1)	(Col. 2)	OTHER THAN A SMALL ENTITY	
FOR:	NO. FILED	NO. EXTRA	RATE	FEE
BASIC FEE				\$ 750.
TOTAL CLAIMS	51 -20=	31	x 18 =	\$ 558.
INDEP CLAIMS	5 -3=	2	x 84 =	\$ 168.
			SUB TOTAL	\$ 1,476.
			ASSIGNMENT	\$40.
			TOTAL	\$ 1,516.

- ☒ Please charge my Deposit Account No. 19-0033 in the amount of \$ **1,516**. A duplicate copy of this sheet is enclosed.
- ☒ The Commissioner is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account No. 19-0033. A duplicate copy of this sheet is enclosed.
- ☒ Any additional filing fees required under 37 CFR §1.16.
- ☒ Any patent application processing fees under 37 CFR §1.17.

Respectfully submitted,
George O. Saile
GEORGE O. SAILE, REG. NO. 19,572

EXPRESS MAIL CERTIFICATE

Express Mail No. **EV313927030US**

I hereby certify that this correspondence is being deposited with the United States Postal Service as Express Mail in an envelope addressed to Assistant Commissioner of Patents, Alexandria, VA, 22313-1450. Applicant and/or Attorney requests the date of deposit as the Filing Date.

9/8/03
Date of deposit

George O. Saile 9/8/03
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22387 U.S. PTO
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